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## Intriguing properties of unusual silicon nanocrystals†

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Solar cell technologies are highly dependent on silicon materials and novel nanoclusters with optimal electronic properties. Based on a recent study on ultrastable silicon nanoclusters, an analysis of the effects of modifications of those nanocrystals by carboxylation, amidation, hydroxylation and halogenation has been performed using quantum mechanical methods of study. Here we report the gaps, electronic structures, absorption spectra, and effects on the charge-transfer potential of a collection of modified silicon nanoclusters. The results show that the pristine silicon clusters retain the highest charge-transfer properties and that halogenation impacts on the charge-transfer effects in a proportional fashion to the electronegativity of the employed halogens. Modification with organic molecules does not improve charge-transfer properties, and gives instead the highest reduction of charge-transfer potentials of the silicon clusters. The effects of the modification have also been studied in context with the orbital configurations through wave function analysis, which reveals that the electrostatic properties of the nanoclusters are mainly represented by a significant polarization of the electrostatic energy between the peripheral regions of the clusters and their core, a feature particularly well-preserved in the pristine silicon clusters. Modifying the particles by adding an extra atom at their core shows significant effects on the molecular orbital properties (HOMO/LUMO). However, this modification does not contribute to an actual increase in charge-transfer integrals. The modifications induce, however, interesting effects on the overall configuration of the clusters; *i.e.*, they increase the aromatic character of the inter-atomic bonding pattern. Halogenation has the highest effect on improving aromatic properties for the silicon clusters, where chlorination gives the highest degree of aromaticity. This study introduces valuable electronic data for engineering novel silicon nanoclusters for application in solar cell technologies, computing units, and other fields such as in aerospace engineering.

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## Introduction

Global energy resources are a key aspect of modernization and modern society developments. With the increasing use of technological and microelectronic solutions and consumables in society, global energy demands bring challenges to research

in energy with sustainable and green technologies.<sup>1,2</sup> In this context, solar cells and silicon based technologies represent a crucial point for the development of green and renewable energy solutions, with particular emphasis on photovoltaic cells, wafer technologies, polymer-based photocatalytic membranes and cells, and nanowires.<sup>3-7</sup> Silicon is ubiquitous in nature, and exerts excellent semi-conductive, conductive and insulating properties in bulk materials. Moreover, in the form of nanocrystals and nanoclusters, silicon can be tuned to operate at higher conductivities than in bulk materials, and be also used for high-energy applications in combination with transition metals. Methods for synthesizing nano-sized silicon clusters are often based on plasma and ion beam techniques<sup>8,9</sup> which permit to control the particle size and, thus, their band gaps. In addition, UV-emitting properties of these particles can be obtained in co-synthesized metallic nanoislands *via* the formation of plasmon-induced electric fields.<sup>9</sup> Silicon nanocrystals and clusters can have very small band gaps,<sup>10</sup> and be used as nanodots and quantum dots in photonics and micro-technologies.<sup>11-13</sup> In addition, such clusters can be used for

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nanowire technologies, as they can exert a quantum confinement effect<sup>14</sup> *via* their small diameters yielding a direct band gap that increases with decreasing nanowire diameter.<sup>15</sup>

Recent research on modifications of silicon clusters has shown that nanocluster size and morphology affect the quantum mechanical properties of the clusters.<sup>16</sup> Also, halogenation of silica has shown improved interatomic potentials for silica ensembles,<sup>17</sup> and nanoparticles of silica have been found to be excellent materials for conductive matrixes in relevant technologies such as nanosensors.<sup>18</sup> The modifications of silica by halogenation can in other words be a very valuable avenue of research for the synthesis of novel nanocrystals, as halogens retain particular electronic properties (*i.e.* high electronegativity, low ionization potentials) given lower nuclear shielding effects on their valence electrons.

The development of new silica-based and silicon-based technologies relies, however, on accurate and sound predictions for nanocrystals, where quantum mechanical studies represent an indispensable resource in the prediction of properties for molecular and electronic ensembles of crystals, lattices and atomistic units.<sup>16,19–21</sup> With the use of quantum mechanics, electronic properties such as charge-transfer potentials,<sup>22</sup> electron delocalization,<sup>21</sup> bond metallicity,<sup>23</sup> electron localization,<sup>24</sup> aromaticity,<sup>25</sup> electronic gaps are generated, functioning directly as a basis for the structuring and synthesis of nanomaterials and nanocrystals.

One example of those promising new silicon materials is presented by over-coordinated hydrogenated silicon clusters as the Si<sub>19</sub>H<sub>12</sub> nanocrystal.<sup>21</sup> This entity is composed of three parallel, planar hexagons with one additional Si atom close to the cluster center causing its hypervalent and electron-deficient character. In principle, all ring structures suffer from more or less strain. Due to the electron-deficient nature of the Si<sub>19</sub>H<sub>12</sub> nanocrystal, however, the traditional approach to estimate strain energies based on homodesmotic reactions<sup>26</sup> might lead to completely erroneous results.<sup>27</sup> Based on both *ab initio* molecular dynamics (AIMD) simulations and recent experimental measurements, it has been demonstrated that the associated ring strain in the Si<sub>19</sub>H<sub>12</sub> nanocrystal is completely negligible due to the high degree of electron deficiency in the atomic bonds.<sup>27</sup> In an earlier study, it had actually been shown that the electron deficiency induces extensive electron delocalization that causes those clusters to be ultrastable and to possess aromatic-like properties.<sup>28</sup> We like to remind here that “ultrastable” does not necessarily mean global minimum energy structure, but rather that the electron deficiency induces strong electron delocalization that leads to non tetrahedral entities that are more stable than their tetrahedral counterparts. Consequently, the use of those nontetrahedral nanocrystals for the fabrication of nanodevices in realistic plasma reactors has been predicted.<sup>29</sup>

In this context, the present study reports on an extensive quantum chemical study of a series of modifications on hydrogenated silicon nanoclusters, with additional insertion of one Si or one Ge atom close to the center of the selected Si<sub>18</sub>X<sub>12</sub> nanostructures, where X = F, Cl, Br, NH<sub>2</sub>, COOH, and OH. The different properties, including geometries,

absorption spectra, electronic structures, reactivities, charge-transfer integrals, and other critical features of the electronic properties are used to study the effects on the modified clusters.

The results from this study supply valuable information for the further development of novel energy technologies and report key features of the electronic effects for chemically modified silicon nanoclusters with different sizes and morphologies and elucidate the effects at the electronic structure level.

## Materials and methods

### Choice of structures

All structures and modifications (see next paragraph) resulted in a diameter class of approximately 1 nm. The origin of these structures is from an earlier work by Vach<sup>21</sup> based on the self-assembly dynamics during the nucleation process in realistic low-temperature and low-pressure plasma-reactor synthesis.<sup>28–30</sup> Given the low-diameter size of these nanoparticles, their use and application is expected to be as nanocolloids, suspensions or as crystals. These can be applied in solar technologies *via* suitable routes of manufacturing. Parts of this manufacturing process can be carried out *via* methods from Greene and colleagues on ZnO nanorods at start-dimensions of 5 nm.<sup>31</sup> If successfully synthesized, the experimental electronic properties derived for this selection of structures are expected to be coherent with the data derived throughout this text and is restricted to the given dimensions. Larger particle classes must be explored in a separate study and require additional investigation. The authors chose furthermore to investigate hexagonal structures of silicon, as those from ref. 28–30 because of their potential presence of over-coordinated states from the abovementioned synthesis method by plasma-reactors. The hexagonal structures are therefore of interest to the authors for modification effects by passivization.

### Gaussian calculations

All structures were prepared in Gaussian 09 rev. A.01 (ref. 32) and optimized using the B3LYP functional<sup>33</sup> with the 6-31G(d) basis set.<sup>34</sup> A set of structures encompassed a C<sub>6h</sub> cluster of 18 silicon atoms arranged in a hexagonal crystal system (Fig. 1A). Another two sets of clusters were modeled by introducing either an additional silicon or germanium atom close to the center of the 18 silicon atom structure of the first set (Fig. 1B and C). Each of the nanostructures was subjected to modifications of their peripheral hydrogens, replacing these by selected halogens (Br, Cl and F), and NH<sub>2</sub>, COOH, and OH groups. The latter two modifications were added to investigate the effects of oxygen atoms on the nanocluster electronic structures. Optimization calculations of those structures were carried out to find the optimized minima on the potential energy surface. Frequency calculations did not show any imaginary frequencies for the optimized molecules.

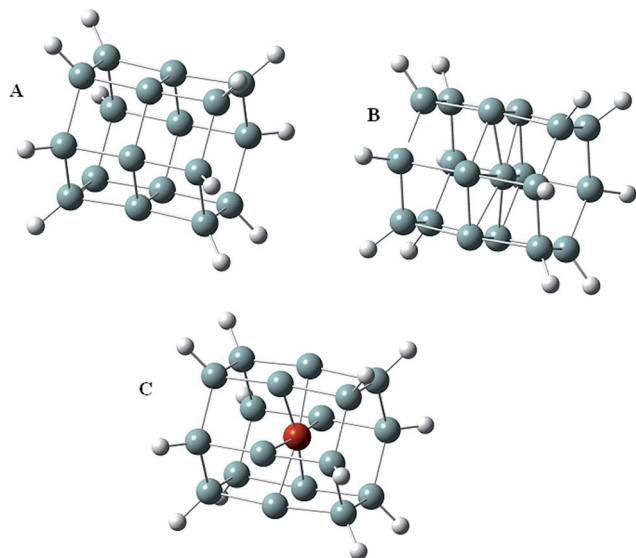


Fig. 1 Optimized structures of A: empty  $\text{Si}_{18}\text{H}_{12}\text{Si}$  NCs arranged in a  $C_{6h}$  symmetry of hexagonal crystal geometry; B:  $\text{Si}_{19}\text{H}_{12}$ , the 19<sup>th</sup> Si atom situated in the center of the lattice structure. C:  $\text{Si}_{18}\text{GeH}_{12}$ , Ge atom situated in the center of the lattice structure.

### Average local ionization energies

The average local ionization energy,  $\bar{I}(\mathbf{r})$ , is interpreted as a means of estimating the sites of the more reactive electrons in a molecule or cluster and is given by:<sup>35,36</sup>

$$\bar{I}(\mathbf{r}) = \frac{\sum_i \rho_i(\mathbf{r}) |\varepsilon_i|}{\rho(\mathbf{r})} \quad (1)$$

where  $\rho_i(\mathbf{r})$  is the electronic density of the  $i^{\text{th}}$  occupied atomic or molecular orbital and  $\varepsilon_i$ , the energy of  $i^{\text{th}}$  orbital, is its focus being upon the point in space rather than upon a particular orbital. The computed  $\bar{I}(\mathbf{r})$  is evaluated on the molecular surface and labeled  $\bar{I}_s(\mathbf{r})$ . The minima of  $\bar{I}_s(\mathbf{r})$ ,  $\bar{I}_{s,\text{min}}$ , correspond to the least tightly-held electrons, which should be the most reactive sites to electrophilic or free radical attack.<sup>35,36</sup>

### Optical absorption spectra

Optical absorption spectra were calculated using time-dependent density-functional theory (TD-DFT) implemented in the Gaussian09 package.<sup>32</sup> Minimum energy structures of all investigated clusters were employed as configurations for the TD-DFT calculations. The hybrid, non-local exchange and correlation functional of Becke, Lee, Parr, and Yang (B3LYP) and the 6-31G(d) basis set were used. The validity of this basis set was verified by having performed several calculations with the 6-311++G(d,p) basis set that gave essentially the same results. For each structure, 150 singlet excited states were computed for the absorption spectra.

### Wavefunction and NICS analyses

Natural population analysis (NPA) was conducted using the NBO3.1 module embedded in the Gaussian 09 package.<sup>32</sup>

Density of states analysis, orbital interaction diagram analysis, quantitative analysis of electrostatic potential on vdW surfaces, atoms in molecules (AIM) analysis, Mayer and Laplacian bond order calculations, as well as electron localization function (ELF) analysis were all performed using Multiwfn 3.3.6.<sup>37</sup> Nucleus-independent chemical shifts (NICS) were calculated with Gaussian 09.<sup>32</sup> All wavefunction analyses were based on B3LYP/6-31G\* wavefunctions, while NICS analysis was carried out at B3LYP/6-31+G\* level.

### Charge-transfer properties

The calculation of the charge-transfer integrals is carried out through solving the electronic coupling,  $V$ , between two molecules of the same species, such as two  $\text{Si}_{19}\text{H}_{12}$  molecules for instance. The results are presented in Table 4. The methods is carried out according to ref. 38 and resolves the equation:  $V = (J - S(\varepsilon_1 - \varepsilon_2)/2)/(1 - S^2)$ . Here,  $J$  is the interaction integral, defining the level of interaction between the nucleus and the electron density on the neighbor nucleus,  $S$  is the overlap integral and the epsilons are the eigenvalues of energies of each fragment under consideration (HOMO-for n-type transfer, and LUMO for p-type transfer). The charge-transfer integrals were calculated using the Amsterdam Density Functional (ADF) package,<sup>39,40</sup> with the PW91 method at the triple-zeta level with polarization functions (TZP).<sup>34,41</sup> The approach relies first on solving the single point state for each modified nanocluster deriving from the Gaussian calculations (*vide supra*), which was subsequently considered as a fragment in the paired

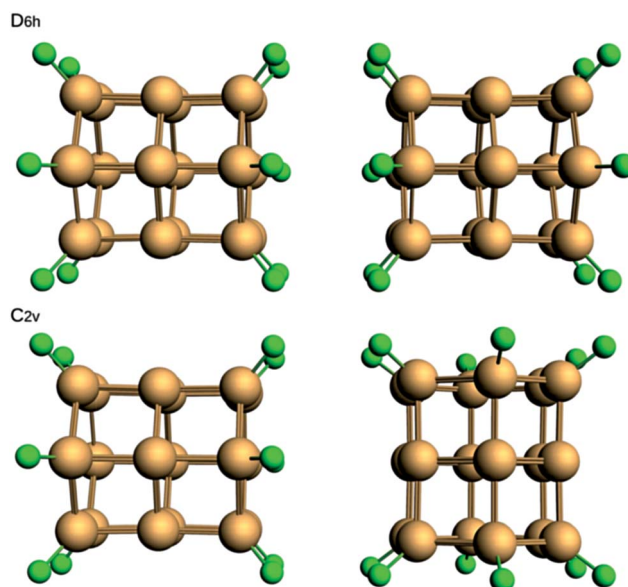


Fig. 2 Symmetry for pairs of clusters for the charge-transfer study. Each cluster was arranged co-axially to the other central axis in a  $D_{6h}$  symmetry (top) and perpendicularly in a  $C_{2v}$  symmetry (bottom). The nanoclusters with halogens were set at a distance between the halogen atoms (example above: fluorine atoms) of 2.9 Å before optimization. Groups with compatible polar interactions (COOH,  $\text{NH}_2$ , and OH) were set at an initial distance of 2.5 Å. Pristine Si-clusters were set at an initial distance of 2.5 Å between the hydrogen atoms.

nanocluster calculations (pairs of identical clusters) (Fig. 2). All modified single clusters were subjected to an enforced symmetry imposition. The symmetry tolerance was set to  $10^{-10}$  Å on all coordinates for the single nanocluster calculations. Non-halogenated clusters were subjected to geometry optimization with the PW91 method before pair-wise calculations. The pair-wise calculations of the modified clusters were carried by a single-point calculation with enforced symmetry of pairs (Fig. 2). The inter-cluster distance was defined by 2.9 Å between each symmetrically aligned halogen pair, after a careful evaluation of a series of non-covalent bond lengths. The symmetry tolerance was set to 0.1 Å for the pair-wise calculations. The method for solving the charge-transfer integrals is described in the ADF manual.<sup>39</sup> The  $\text{Si}_{19}\text{H}_{12}$  clusters were arranged in a  $D_{6h}$  and  $C_{2v}$  symmetry manually, without using the “symmetrize” function in ADF. The distance was set as above, to 2.9 Å between two separate hydrogen atoms. Subsequently, the two  $\text{Si}_{19}\text{H}_{12}$  pairs were subjected to a geometry optimization with the PW91 method. The finalized outputs were then subjected to charge-transfer calculations, *via* the approach described above and in the ADF manual.<sup>39</sup>

## Results and discussion

### Orbital and gap analyses

The empty  $\text{Si}_{18}\text{H}_{12}$  and the endohedrally filled  $\text{Si}_{19}\text{H}_{12}$  and  $\text{Si}_{18}\text{GeH}_{12}$  silicon nanocrystals (Si NCs) were optimized at a B3LYP/6-31 G(d) level of theory and the HOMO–LUMO gaps are shown in Fig. 3. The geometry optimizations were performed without any symmetry constraints. In some endohedrally filled Si NCs, the inserted Si or Ge atoms deviate from the center of the cluster by 0.03–0.38 Å (Table 1). The temporal periodic change of this distance was the subject of a parallel

investigation for the  $\text{Si}_{19}\text{H}_{12}$  nanocrystal.<sup>29</sup> One of the effects caused by the 19<sup>th</sup> atom can be seen in the energy change between the highest occupied molecular orbital  $E_{\text{HOMO}}$  and the lowest unoccupied molecular orbital  $E_{\text{LUMO}}$  (Table 1). Table 1 shows that the narrowest HOMO–LUMO gaps are found for silicon clusters where the 19<sup>th</sup> atom is close to the core with a most favorable modification of the peripheral atoms by hydrogenation and hydroxylation (Table 1, Fig. 3). In general, the HOMO–LUMO gap decreases from the empty  $\text{Si}_{18}\text{X}_{12}$  to the filled  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$  crystals. The effect of reduced gap width of the clusters with 19 lattice atoms, compared to 18-atom clusters is caused by the electronic configuration difference between Ge and Si which results in a nearly 30% expansion of the HOMO–LUMO gaps when the former is applied for the halogenated variants. This large difference results from the existence of the 3d electrons of germanium which induce a strong electron–electron repulsion below the valence shell of germanium, compared to the less electron-populated 3s orbital of silicon. The result of the presence of the fully occupied 3d orbital in germanium is a lower shielding effect on the valence electrons of germanium, than the 3s induce on the 3p electrons of silicon. The reduced shielding effect arising from stronger electron–electron repulsions in the 3d orbitals of germanium contributes in making the valence electrons less stable between the Ge and Si atoms, expanding the HOMO–LUMO gap.

The effects on the electronic gaps by halogenation display an electronic behavior which leads to the expansion of the excitation gaps. Interestingly enough, when comparing the 19-atom clusters to the 18-atom clusters ( $\Delta E_{18} - \Delta E_{19}$ ), the more the halogen is changed from Br > Cl > F, the larger the decrease of the overall excitation gap is. A fluorinated cluster of 19 atoms compared to a fluorinated cluster of 18 atoms has the largest change in gap (1.044 eV), followed by 0.966 eV for chlorine and

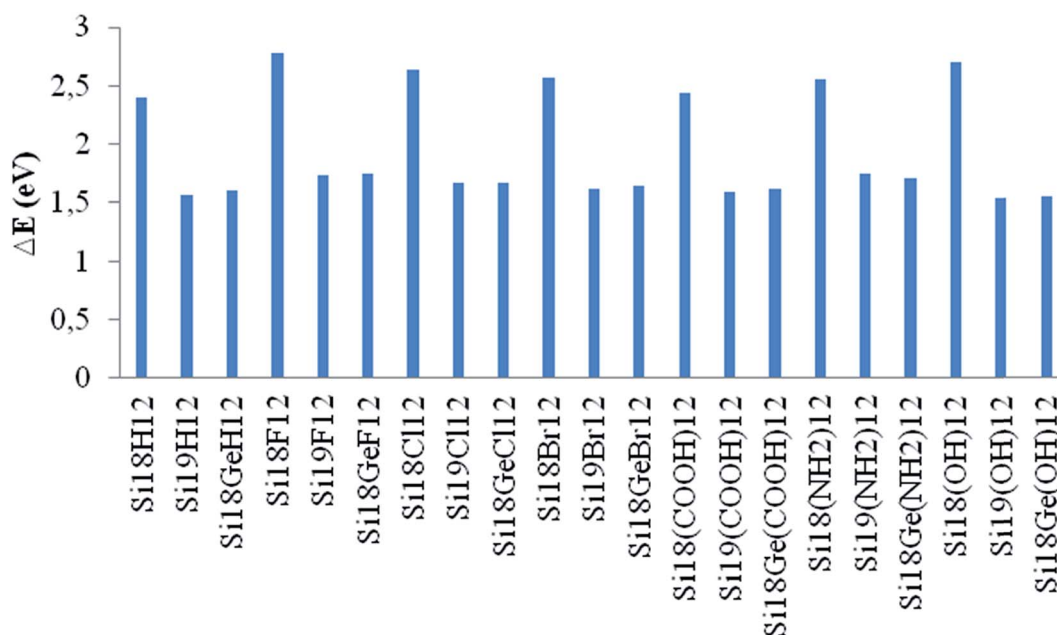


Fig. 3 The HOMO–LUMO gap  $\Delta E$  (eV) of studied silicon nanoclusters calculated at the B3LYP/6-31G(d) level of theory.

**Table 1** The calculated first frequencies, HOMO and LUMO energies, HOMO–LUMO band gaps, dipole moment, and distance of central Si/Ge from center of the studied Si NICs

Cluster	First frequency	$E_{\text{HOMO}}$ (a.u.)	$E_{\text{LUMO}}$ (a.u.)	$\Delta E$ (eV)	Dipole moment	Distance from center ( $\text{\AA}$ )
Si <sub>18</sub> H <sub>12</sub>	102.9	-0.2081	-0.1198	2.403	0.0005	—
Si <sub>19</sub> H <sub>12</sub>	88.5	-0.1698	-0.1123	1.565	1.1429	0.27
Si <sub>18</sub> GeH <sub>12</sub>	29.2	-0.1713	-0.1124	1.600	0.5691	0.15
Si <sub>18</sub> F <sub>12</sub>	59.4	-0.2412	-0.1392	2.775	0.0001	—
Si <sub>19</sub> F <sub>12</sub>	56.2	-0.1929	-0.1292	1.731	0.0093	0.00
Si <sub>18</sub> GeF <sub>12</sub>	68.8	-0.1939	-0.1297	1.747	0.0017	0.00
Si <sub>18</sub> Cl <sub>12</sub>	46.4	-0.2476	-0.1508	2.632	0.0003	—
Si <sub>19</sub> Cl <sub>12</sub>	40.6	-0.2053	-0.1440	1.666	0.0044	0.00
Si <sub>18</sub> GeCl <sub>12</sub>	49.7	-0.2057	-0.1446	1.662	0.0015	0.00
Si <sub>18</sub> Br <sub>12</sub>	27.6	-0.2342	-0.1400	2.564	0.0001	—
Si <sub>19</sub> Br <sub>12</sub>	34.2	-0.1929	-0.1334	1.617	0.1090	0.23
Si <sub>18</sub> GeBr <sub>12</sub>	33.3	-0.1939	-0.1334	1.646	0.0215	0.00
Si <sub>18</sub> (COOH) <sub>12</sub>	10.4	-0.2208	-0.1310	2.443	2.3151	—
Si <sub>19</sub> (COOH) <sub>12</sub>	10.5	-0.1857	-0.1271	1.594	1.7221	0.12
Si <sub>18</sub> Ge(COOH) <sub>12</sub>	12.1	-0.1870	-0.1274	1.621	2.0335	0.00
Si <sub>18</sub> (NH <sub>2</sub> ) <sub>12</sub>	53.1	-0.1524	-0.0582	2.557	0.0839	—
Si <sub>19</sub> (NH <sub>2</sub> ) <sub>12</sub>	50.3	-0.1223	-0.0582	1.743	2.2696	0.38
Si <sub>18</sub> Ge(NH <sub>2</sub> ) <sub>12</sub>	28.8	-0.1163	-0.0533	1.713	1.3193	0.15
Si <sub>18</sub> (OH) <sub>12</sub>	52.9	-0.1912	-0.0920	2.700	0.0027	—
Si <sub>19</sub> (OH) <sub>12</sub>	25.8	-0.1419	-0.0856	1.531	0.0951	0.03
Si <sub>18</sub> Ge(OH) <sub>12</sub>	64.4	-0.1429	-0.0859	1.549	0.0162	0.00

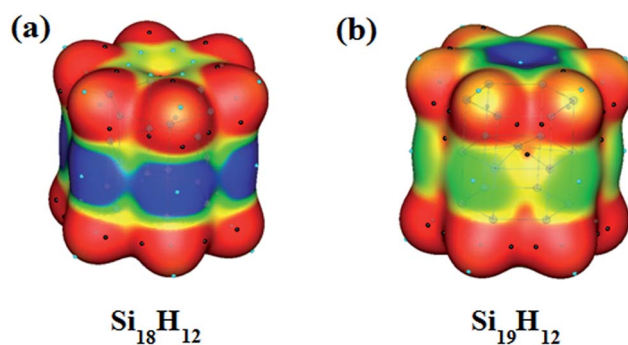
0.947 eV for bromine. This intriguing effect shows that the core silicon atom in the 19 atom clusters has a central role in the conductive pattern of the clusters. This effect on the 19 atom clusters is potentially affected by the ionization potential within the silicon cluster itself, as the increasing levels of electronegativity ( $F_{\text{e.n.}} = 4.0$ ,  $\text{Cl}_{\text{e.n.}} = 3.0$ ,  $\text{Br}_{\text{e.n.}} = 2.8$ ) mainly affect the ionization energies of the inter-atomic valence electrons. The aminated, carboxylated and hydroxylated groups has minor effects on the HOMO–LUMO gaps of the nanoclusters (Table 1, Fig. 3), however, the –OH modifications gave a larger impact on the Si<sub>18</sub> structures than on the Si<sub>19</sub>. This is expected to be caused by the effect of the 19<sup>th</sup> silicon atom, which is described in the section concerning the wavefunction analysis. The effects of the other modifications are also reported further during the wavefunction analysis.

### Average local ionization energies

A local property that has often been used in relation with surface reactivity is the average local ionization energy, defined by eqn (1). Fig. 4 shows the  $\bar{I}_{\text{S}}(\mathbf{r})$  plotted on the  $\rho = 0.001$  a.u. molecular surface for Si<sub>18</sub>H<sub>12</sub> and Si<sub>19</sub>H<sub>12</sub>. It is seen that silicon itself has very reactive electrons, as depicted by the relatively low  $\bar{I}_{\text{S},\text{min}}$  values. The lowest  $\bar{I}_{\text{S},\text{min}}$  are associated with the middle-layer silicon atoms; these  $\bar{I}_{\text{S},\text{min}}$  have values of about 7.4 eV (Table 1). These sites, thus, correspond to the least tightly-held electrons, which should be the most reactive sites to electrophilic or to free radical attack. It is evident from Table 2 that the magnitude of the  $\bar{I}_{\text{S},\text{min}}$  associated with the silicon atoms depends upon the electron-withdrawing/donating power of the X group. Also apparent is that the presence of electron-donating groups (NH<sub>2</sub> and OH) results in lower  $\bar{I}_{\text{S},\text{min}}$  values while the electron-withdrawing COOH substituent leads to higher  $\bar{I}_{\text{S},\text{min}}$

values. Table 2 shows also another interesting feature, where the  $\bar{I}_{\text{S},\text{min}}$  values of the systems tend to increase as the size of the substituted halogen increases, which implies a decreasing effect on the ionization energy by the electronegativity of the halogen. In other words, the halogens give an increase in average ionization potential and higher chemical stabilization of the silicon nanoparticles.

As discussed in an earlier work,<sup>21</sup> electron delocalization in electron-deficient hydrogenated silicon Si<sub>19</sub>H<sub>12</sub> nanocrystals leads to the induction of an aromatic-like behavior of the electrons, yielding a higher degree of electron sharing among the cage atoms. This may also affect the average local ionization energies associated with silicon atoms. As a result of this electron delocalization, we show in Fig. 4b that the  $\bar{I}_{\text{S}}(\mathbf{r})$  values on the side of the Si<sub>19</sub>H<sub>12</sub> nanostructure are quite different than



**Fig. 4** Computed average local ionization energy  $\bar{I}_{\text{S}}(\mathbf{r})$  on the 0.001 a.u. molecular surface of Si<sub>18</sub>H<sub>12</sub> (a) and Si<sub>19</sub>H<sub>12</sub> (b). Color ranges in eV: red > 9.3, yellow 8.4–9.3, green 7.5–8.4, blue < 7.5. Light blue circles denote the positions of the  $\bar{I}_{\text{S}}(\mathbf{r})$  minima, the  $\bar{I}_{\text{S},\text{min}}$ .

those of the  $\text{Si}_{18}\text{H}_{12}$  one. We find  $\bar{I}_{s,\min}$  to be 6.6 eV for  $\text{Si}_{19}\text{H}_{12}$ , leading to an approximated activation of 0.8 eV. Comparison with the  $\bar{I}_{s,\min}$  of  $\text{Si}_{18}\text{H}_{12}$  indicates that the surface reactivity of the nanocrystal is clearly modified after the Si or Ge insertion. What is especially notable is the significant reduction in  $\bar{I}_{s,\min}$  for the insertion of a silicon atom. The results reveal that the silicon insertion tends to activate the surface toward electrophilic/radical attack. Such a different reactivity pattern between the  $\text{Si}_{18}\text{H}_{12}$  and  $\text{Si}_{19}\text{H}_{12}$  can be attributed to the delocalization of p-electrons that are delocalized between the center silicon atom and its neighbors. Table 2 reveals that the insertion of the center Ge atom also tends to activate the  $\text{Si}_{18}\text{H}_{12}$  surface toward electrophilic/radical attack, although the effect is weaker than for Si insertion. This is most likely due to the different charge transfer effects between the inserted atom and  $\text{Si}_{18}\text{H}_{12}$ , which will be discussed in the following and to the lower ionization energy of germanium in its elemental form (7.8994 eV) compared to silicon (8.1517 eV).

### Absorption spectra

Maximum absorption wavelengths, oscillator strengths, and molar absorption coefficients of all investigated clusters in the IR, VIS, and UV regions are summarized in Table 3. All  $\text{Si}_{19}\text{X}_{12}$  (with X = H, Br, Cl, F, COOH,  $\text{NH}_2$ , and OH) and  $\text{Si}_{18}\text{GeX}_{12}$  clusters can absorb light in the three spectral regions, whereas none of the  $\text{Si}_{18}\text{X}_{12}$  clusters exhibits absorption in the IR. The  $\text{Si}_{18}\text{H}_{12}$  cluster can only absorb in the UV. Those results are consistent with the absorption spectra calculations for  $\text{Si}_{19}\text{H}_{12}$  and  $\text{Si}_{18}\text{H}_{12}$  clusters using TD-DFT/6-311++G(d,p).<sup>21</sup> The extension of the absorption spectra of  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$  clusters up to the IR is assigned to the insertion of the central over-coordinated Si or Ge atoms. The role of endohedral atoms

(Si or Ge); *i.e.*, with over-coordinated Si or Ge atoms, on the ability of nanocrystals to absorb in the VIS and IR can be definitively demonstrated when comparing with  $\text{Si}_n\text{H}_{n-1}\text{M}$  clusters (with M = H, Cl, and F;  $n = 20, 24, 26,$  and  $28$ )<sup>42</sup> which have no over-coordinated Si atoms and display absorption strictly limited to the UV region. This observation especially holds for the tetrahedral silicon fullerene  $\text{Si}_{20}\text{H}_{20}$  that has quite the same size of about 1 nm. In general, standard tetrahedral hydrogenated silicon clusters of this size show absorption only in the UV and may absorb light in the VIS and IR only when toxic or expensive metal groups (as PbS, PbSe, CdS, CdSe, Au, or Cr) are incorporated into them.<sup>43–52</sup> The wide absorption spectral range of the investigated  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$  clusters might open immediate applications in the most various fields, for instance, photovoltaic devices and cancer treatment.<sup>21</sup>

### Charge-transfer integrals

Charge-transfer integrals report the energy necessary for a charge transfer to take place between two or several molecules. As aforementioned, high values indicate non-optimal charge-transfer, while low values indicate optimal charge-transfer.

Charge-transfer integrals are valuable to estimate the efficiency of molecules or nanoclusters as conductive units in electronic devices such as field-effect transistors, photovoltaic cells, light-emitting diodes, nanophotonic devices, nanowires, nanoarrays, and other similar structures. Charges conducted across a material or a set of molecules move either in p-modes (hole-to-hole) or n-modes (occupied orbital to occupied orbital). Charge-transfer integrals are useful in determining the optimal mode of the conductive operation of the materials, and can be used to estimate the most feasible mode of electronic operation of the material in an electronic operation mode, in surface coating materials, components in nano-devices, or as crystalline units in solar cell wafers.

The charge-transfer integrals are shown in Table 4, where the charge-transfer values for the two main geometries  $C_{2v}$  and  $D_{6h}$  of each cluster pair are also reported in a summed total for simplicity of interpreting the results. The cluster with optimal charge transfer integrals, both in p- and n-mode of operation is the native  $\text{Si}_{18}\text{H}_{12}$  cluster proposed by Vach and colleagues.<sup>21</sup> The insertion of a 19<sup>th</sup> silicon atom at the core has a reductive effect on the charge-transfer integrals for the pristine Si–H cluster, affecting in particular its p-type mode of operation integral. All modifications result in a reduction of charge-transfer potential, with emphasis on COOH and  $\text{NH}_2$ , as well as OH. This effect is caused by the electron-withdrawing effects that nitrogen and oxygen have on the carbon atoms that would otherwise be bonded to hydrogens. A second cause of this is the electronic repulsion that arises between oxygen groups of two nanoparticles next to one another. This repulsion is likely to affect the charge-transfer potential. Electronic analysis of paired clusters has not been performed given our present limitations in computational time; however, a set of new electronic studies

Table 2 Computed  $\bar{I}_s(r)$  minima, the  $\bar{I}_{s,\min}$  for all investigated systems

System	$\bar{I}_{s,\min}$ (eV)
$\text{Si}_{18}\text{H}_{12}$	7.4
$\text{Si}_{18}\text{F}_{12}$	8.2
$\text{Si}_{18}\text{Cl}_{12}$	8.5
$\text{Si}_{18}\text{Br}_{12}$	8.6
$\text{Si}_{18}(\text{COOH})_{12}$	8.4
$\text{Si}_{18}(\text{OH})_{12}$	6.8
$\text{Si}_{18}(\text{NH}_2)_{12}$	6.6
$\text{Si}_{19}\text{H}_{12}$	6.6
$\text{Si}_{19}\text{F}_{12}$	7.5
$\text{Si}_{19}\text{Cl}_{12}$	7.6
$\text{Si}_{19}\text{Br}_{12}$	7.7
$\text{Si}_{19}(\text{COOH})_{12}$	7.1
$\text{Si}_{19}(\text{OH})_{12}$	6.0
$\text{Si}_{19}(\text{NH}_2)_{12}$	5.9
$\text{Si}_{18}\text{GeH}_{12}$	7.2
$\text{Si}_{18}\text{GeF}_{12}$	8.1
$\text{Si}_{18}\text{GeCl}_{12}$	8.3
$\text{Si}_{18}\text{GeBr}_{12}$	8.1
$\text{Si}_{18}\text{Ge}(\text{COOH})_{12}$	8.2
$\text{Si}_{18}\text{Ge}(\text{OH})_{12}$	6.6
$\text{Si}_{18}\text{Ge}(\text{NH}_2)_{12}$	6.5

**Table 3** Maximum absorption wavelengths ( $\lambda_{\text{max}}$ ), oscillator strengths ( $f$ ), and molar absorption coefficients ( $\epsilon_{\text{max}}$ ) of all investigated clusters computed with TD-DFT/6-31G(d) in the IR, VIS, and UV regions

Structure	IR			VIS			UV		
	$\lambda_{\text{max}}$ (nm)	$f$	$\epsilon_{\text{max}}$ ( $\text{M}^{-1} \text{cm}^{-1}$ )	$\lambda_{\text{max}}$ (nm)	$f$	$\epsilon_{\text{max}}$ ( $\text{M}^{-1} \text{cm}^{-1}$ )	$\lambda_{\text{max}}$ (nm)	$f$	$\epsilon_{\text{max}}$ ( $\text{M}^{-1} \text{cm}^{-1}$ )
Si <sub>19</sub> H <sub>12</sub>	814.61	0.0234	1872.00	411.49	0.0146	1168.00	295.44	0.0947	7576.00
Si <sub>19</sub> Br <sub>12</sub>	1006.04	0.0398	4643.33	437.95	0.0148	1726.66	293.72	0.1015	11 841.67
Si <sub>19</sub> Cl <sub>12</sub>	956.86	0.041	4100.00	445.08	0.0133	1330.00	281.75	0.1247	12 470.00
Si <sub>19</sub> F <sub>12</sub>	894.17	0.0356	2136.00	420.11	0.0096	576.00	275.37	0.1822	10 932.00
Si <sub>19</sub> (COOH) <sub>12</sub>	934.22	0.0323	7177.78	439.71	0.0063	1400.00	356.08	0.0421	9355.56
Si <sub>19</sub> (NH <sub>2</sub> ) <sub>12</sub>	800.72	0.0300	6000.00	534.30	0.0129	2580.00	317.74	0.0722	14 440.00
Si <sub>19</sub> (OH) <sub>12</sub>	894.04	0.0373	1790.40	461.73	0.0153	734.40	292.89	0.2221	10 660.80
Si <sub>18</sub> GeH <sub>12</sub>	881.23	0.0276	3154.29	413.64	0.0061	697.14	295.20	0.0673	7691.43
Si <sub>18</sub> GeBr <sub>12</sub>	976.5	0.0417	4170.00	501.36	0.0188	1880.00	292.28	0.1302	13 020.00
Si <sub>18</sub> GeCl <sub>12</sub>	964.59	0.0385	3300.00	487.33	0.0174	1491.43	309.04	0.1277	10 945.71
Si <sub>18</sub> GeF <sub>12</sub>	892.13	0.0336	2240.00	458.41	0.0142	946.67	274.39	0.1671	11 140.00
Si <sub>18</sub> Ge(COOH) <sub>12</sub>	995.05	0.0414	2957.14	412.26	0.0354	2528.57	334.64	0.1229	8778.57
Si <sub>18</sub> Ge(NH <sub>2</sub> ) <sub>12</sub>	904.11	0.0388	5432.00	486.00	0.0159	2226.00	320.62	0.0909	12 726.00
Si <sub>18</sub> Ge(OH) <sub>12</sub>	891.63	0.0356	1708.80	507.91	0.0195	936.00	292.78	0.2126	10 204.80
Si <sub>18</sub> H <sub>12</sub>							262.30	0.0988	8892.00
Si <sub>18</sub> Br <sub>12</sub>				406.58	0.0074	575.56	277.19	0.1645	12 794.44
Si <sub>18</sub> Cl <sub>12</sub>				403.65	0.0060	360.00	270.04	0.1989	11 934.00
Si <sub>18</sub> F <sub>12</sub>				406.65	0.0031	241.11	257.93	0.1662	12 926.67
Si <sub>18</sub> (COOH) <sub>12</sub>				400.96	0.0055	2200.00	378.14	0.0310	12 400.00
Si <sub>18</sub> (NH <sub>2</sub> ) <sub>12</sub>				403.21	0.0159	3180.00	284.65	0.0966	19 320.00
Si <sub>18</sub> (OH) <sub>12</sub>				433.55	0.0026	156.00	270.36	0.2642	15 852.00

of pairs of clusters can confirm these observations further. The halogenated modifications preserve still a significant charge-transfer potential, compared to the organic-modified clusters. Insertion of a germanium atom at the core has improving effects primarily for the substitution with NH<sub>2</sub> in p-type operation and OH-clusters; however it does not improve the charge-transfer effective potential of the pristine Si<sub>18</sub>H<sub>12</sub>. In general, the modified nanoclusters with 19 silicon atoms display more optimal charge-conducting characteristics compared to the 18-silicon atom clusters, particularly for Cl, Br and F. When comparing the three Si<sub>19</sub>-halogenated states, the electronegativity of the halogen is critical to modulate the charge-transfer integral, where fluorine with an electronegativity of 4.0 shows the least reducing effects on  $J_{\text{eff}}$  in p-mode of charge-transfer, followed by bromine and chlorine (Table 4). These patterns are not equally well-preserved for the halogenated clusters comprised of 18 silicon atoms, which interestingly, give a better conductive potential in n-mode of operation than the halogenated clusters with 19 silicon atoms. The employed symmetric arrangement of cluster pairs has the highest effect accounting for most clusters. The optimal charge-transfer potential is obtained when the nanoclusters are arranged in a  $D_{6h}$  symmetry, rather than  $C_{2v}$  improving most of the charge-transfer properties in n-type operation. This observation is quite crucial and depends on the linear arrangement of the modification groups, in the  $D_{6h}$  symmetry, all modifications are aligned with maximum interaction surfaces to one another. In a  $C_{2v}$  symmetry, the modifications are disaligned, and have low contact surfaces (Fig. 2).

### Charge distribution

The nature of the X group and the inserted atom must have significant influences on the charge distribution of the Si<sub>18</sub>X<sub>12</sub> clusters. In order to make this point clear, we calculated Natural Population Analysis (NPA) charges for the X groups, the peripheral silicon atoms (*i.e.* the ones linking to the X groups), the middle-layer silicon atoms and the inserted Si or Ge atoms; the results are listed in Table 5. From the table it can be seen that for all Si<sub>18</sub>X<sub>12</sub>, Si<sub>19</sub>X<sub>12</sub> and Si<sub>18</sub>GeX<sub>12</sub> clusters, the X groups possess clearly negative charges, while the peripheral silicon atoms possess large positive charges. This is mainly because silicon has such a small electronegativity (1.90), which is even smaller than hydrogen (2.10). From the charge of the X groups, it is clear that the order of electron-withdrawing ability is F > OH > NH<sub>2</sub> > Cl > COOH > Br > H, and the charge variation trend of the peripheral silicon atoms is inversely correlated with it. In the case of the Si<sub>18</sub>X<sub>12</sub>, the middle-layer silicon atoms have more electrons than the peripheral ones and thus are negatively charged; however, no clear relationship is observed between their charges and the electron-withdrawing ability of the X groups. In both the Si<sub>19</sub>X<sub>12</sub> and Si<sub>18</sub>GeX<sub>12</sub>, the charge of the middle-layer silicon atoms is close to zero, while that of the inserted Si or Ge is quite negative, ranging from  $\sim 0.59$  to  $\sim 0.75$  for Si and from  $\sim 0.76$  to  $\sim 0.89$  for Ge. It is worth noting that the insertion of an atom into the center of the Si<sub>18</sub>X<sub>12</sub> cluster only weakly affects the charge of peripheral silicon atoms; conversely, the exchange of the X group does not only affect the charge of the silicon atoms directly linking to them, but also somewhat affects those beyond them (*i.e.* the middle-layer silicon atoms and the inserted atom). This phenomenon

**Table 4** Charge-transfer properties of the modified silicon nanoclusters. All integrals have to be negative to yield favorable charge-transfer mobility. Fragment energies depict the energies of each molecule in a charge-transfer pair.  $J_{\text{effp}}$ : effective charge-transfer integral (p-mode);  $J_{\text{effn}}$ : effective charge-transfer integral (n-mode). Symmetry types: for "H" "horizontal" ( $C_1$ ) and "P" for "perpendicular" ( $C_1$ ), see respectively  $D_{6h}$  and  $C_{2v}$  orientations in Fig. 2. The non-halogen groups disallow symmetries, however the silicon grids of the two respective non-halogenated nanoparticles are aligned respectively to  $D_{6h}$  and  $C_{2v}$

Cluster pairs	Symmetry	HOMO fragments energy (eV)		LUMO fragments energy (eV)		$J_{\text{effp-mode}}$ (eV)	$J_{\text{effn-mode}}$ (eV)
		$\varepsilon_1$	$\varepsilon_2$	$\varepsilon_1$	$\varepsilon_2$		
Si <sub>18</sub> H <sub>12</sub> × 2	$D_{6h}$	-5.536	-5.536	-4.881	-4.881	-0.340	-0.550
Si <sub>18</sub> H <sub>12</sub> × 2	$C_{2v}$	-5.229	-5.597	-4.635	-4.307	-0.097	-0.034
∑:						<b>-0.437</b>	<b>-0.584</b>
Si <sub>19</sub> H <sub>12</sub> × 2	$D_{6h}$	-4.783	-4.783	-3.761	-3.761	0.052	-0.145
Si <sub>19</sub> H <sub>12</sub> × 2	$C_{2v}$	-4.752	-4.870	-3.683	-3.841	0	0.002
∑:						<b>0.052</b>	<b>-0.143</b>
Si <sub>18</sub> GeH <sub>12</sub> × 2	$D_{6h}$	-4.687	-4.687	-3.787	-3.787	0.051	-0.139
Si <sub>18</sub> GeH <sub>12</sub> × 2	$C_{2v}$	-4.629	-4.778	-3.710	-3.874	0	0
∑:						<b>-0.051</b>	<b>-0.139</b>
Si <sub>18</sub> F <sub>12</sub> × 2	$D_{6h}$	-7.610	-7.610	-6.145	-6.145	0.065	-0.218
Si <sub>18</sub> F <sub>12</sub> × 2	$C_{2v}$	-7.622	-7.514	-6.083	-6.018	0.002	-0.056
∑:						<b>0.067</b>	<b>-0.274</b>
Si <sub>19</sub> F <sub>12</sub> × 2	$D_{6h}$	-5.449	-5.449	-4.486	-4.488	-0.140	0
Si <sub>19</sub> F <sub>12</sub> × 2	$C_{2v}$	-5.553	-5.348	-4.597	-4.441	-0.018	0
∑:						<b>-0.158</b>	<b>0</b>
Si <sub>18</sub> GeF <sub>12</sub> × 2	$C_{2v}$	-5.564	-5.371	-4.695	-4.557	-0.036	-0.018
Si <sub>18</sub> GeF <sub>12</sub> × 2	$D_{2h}$	-5.467	-5.467	-4.652	-4.652	-0.016	-0.073
∑:						<b>-0.052</b>	<b>-0.091</b>
Si <sub>18</sub> Cl <sub>12</sub> × 2	$D_{6h}$	-6.418	-6.418	-5.032	-5.032	0.050	-0.103
Si <sub>18</sub> Cl <sub>12</sub> × 2	$C_{2v}$	-6.423	-6.407	-5.024	-5.004	0	0.002
∑:						<b>-0.050</b>	<b>-0.101</b>
Si <sub>19</sub> Cl <sub>12</sub> × 2	$D_{6h}$	-5.730	-5.730	-4.706	-4.706	-0.114	-0.078
Si <sub>19</sub> Cl <sub>12</sub> × 2	$C_{2v}$	-5.885	-5.660	-4.784	-4.649	0.012	0.010
∑:						<b>-0.102</b>	<b>-0.068</b>
Si <sub>18</sub> GeCl <sub>12</sub> × 2	$D_{6h}$	-5.715	-5.715	-4.700	-4.700	-0.125	-0.090
Si <sub>18</sub> GeCl <sub>12</sub> × 2	$C_{2v}$	-5.781	-5.641	-4.777	-4.653	0.008	0.002
∑:						<b>-0.117</b>	<b>-0.088</b>
Si <sub>18</sub> Br <sub>12</sub> × 2	$D_{6h}$	-6.277	-6.277	-4.941	-4.941	0.087	-0.104
Si <sub>18</sub> Br <sub>12</sub> × 2	$C_{2v}$	-6.270	-6.284	-4.922	-4.911	0.052	0.0028
∑:						<b>0.139</b>	<b>-0.076</b>
Si <sub>19</sub> Br <sub>12</sub> × 2	$D_{6h}$	-5.640	-5.640	-4.557	-4.557	-0.134	-0.017
Si <sub>19</sub> Br <sub>12</sub> × 2	$C_{2v}$	-5.740	-5.543	-4.644	-4.532	0.030	0
∑:						<b>-0.104</b>	<b>-0.017</b>
Si <sub>18</sub> GeBr <sub>12</sub> × 2	$D_{6h}$	-5.719	-5.719	-4.720	-4.720	-0.133	-0.090
Si <sub>18</sub> GeBr <sub>12</sub> × 2	$C_{2v}$	-5.691	-5.692	-4.717	-4.720	-0.014	-0.001
∑:						<b>-0.147</b>	<b>-0.091</b>
Si <sub>18</sub> (COOH) <sub>12</sub> × 2	H	-5.849	-5.947	-4.587	-4.685	-0.018	-0.009
Si <sub>18</sub> (COOH) <sub>12</sub> × 2	P	-5.877	-5.885	-4.638	-4.635	0	-0.002
∑:						<b>-0.018</b>	<b>-0.011</b>
Si <sub>19</sub> (COOH) <sub>12</sub> × 2	H	-5.196	-5.184	-4.387	-4.376	-0.007	0
Si <sub>19</sub> (COOH) <sub>12</sub> × 2	P	-5.189	-5.239	-4.370	-4.433	0.001	-0.008
∑:						<b>-0.006</b>	<b>-0.008</b>
Si <sub>18</sub> Ge(COOH) <sub>12</sub> × 2	H	-5.165	-5.190	-4.400	-4.317	-0.001	-0.004
Si <sub>18</sub> Ge(COOH) <sub>12</sub> × 2	P	-5.229	-5.097	-4.467	-4.338	-0.003	0.001
∑:						<b>-0.004</b>	<b>-0.003</b>
Si <sub>18</sub> (NH <sub>2</sub> ) <sub>12</sub> × 2	$D_{6h}$	-4.098	-4.098	-2.520	-2.520	0.024	-0.060
Si <sub>18</sub> (NH <sub>2</sub> ) <sub>12</sub> × 2	$C_{2v}$	-4.046	-4.258	-2.479	-2.674	0.012	-0.002
∑:						<b>0.036</b>	<b>-0.062</b>
Si <sub>19</sub> (NH <sub>2</sub> ) <sub>12</sub> × 2	$C_2$	-3.336	-3.357	-2.562	-2.576	-0.048	-0.002
Si <sub>19</sub> (NH <sub>2</sub> ) <sub>12</sub> × 2	$C_1$	-3.536	-3.284	-2.753	-2.485	-0.004	-0.002
∑:						<b>-0.052</b>	<b>-0.004</b>
Si <sub>18</sub> Ge(NH <sub>2</sub> ) <sub>12</sub> × 2	$C_2$ (P)	-3.362	-3.413	-2.519	-2.568	-0.069	-0.004
Si <sub>18</sub> Ge(NH <sub>2</sub> ) <sub>12</sub> × 2	$C_2$ (H)	-3.326	-3.354	-2.499	-2.523	-0.059	0
∑:						<b>-0.128</b>	<b>-0.004</b>
Si <sub>18</sub> (OH) <sub>12</sub> × 2	$C_2$	-5.023	-4.855	-3.887	-3.715	0.009	0
Si <sub>18</sub> (OH) <sub>12</sub> × 2	$D_{6h}$	-4.895	-4.895	-3.764	-3.764	0.013	0.059
∑:						<b>0.022</b>	<b>0.059</b>



Table 4 (Contd.)

Cluster pairs	Symmetry	HOMO fragments energy (eV)		LUMO fragments energy (eV)		$J_{\text{effp-mode}}$ (eV)	$J_{\text{effn-mode}}$ (eV)
		$\epsilon_1$	$\epsilon_2$	$\epsilon_1$	$\epsilon_2$		
$\text{Si}_{19}(\text{OH})_{12} \times 2$	$C_2$	-4.265	-4.040	-3.492	-3.295	-0.007	-0.008
$\text{Si}_{19}(\text{OH})_{12} \times 2$	$D_{6h}$	-4.061	-4.061	-3.300	-3.300	-0.093	-0.002
$\Sigma$ :						<b>0.100</b>	<b>0.010</b>
$\text{Si}_{18}\text{Ge}(\text{OH})_{12} \times 2$	$C_2$	-4.180	-4.226	-3.468	-3.51	-0.011	-0.024
$\text{Si}_{18}\text{Ge}(\text{OH})_{12} \times 2$	$D_{6h}$	-4.135	-4.135	-3.425	-3.425	-0.069	-0.035
$\Sigma$ :						<b>-0.080</b>	<b>-0.049</b>

is somewhat expected, because insertion only brings one additional atom into the system, while exchange of the X group involves as many as 12 groups simultaneously and thus should impose relatively higher influence on the charge of the silicon atoms.

To further reveal the electronic structure characteristics of the inserted atoms, the configuration of their valence electrons were obtained *via* NPA analysis and are shown as the last column of Table 5. From the data one can see that there is no notable difference between the inserted Si and Ge in electronic configuration, and that the electron occupation number of the valence  $p_z$  atomic orbital (the one parallel to the symmetry axis of the clusters) is clearly higher than that of the  $p_x$  and  $p_y$  atomic orbitals.

### Density of states (DOS)

The chlorine halogenated  $\text{Si}_{18}$  is a representative nanocluster in the series of silicon clusters that will be subjected to a complete DOS analysis. To better understand how the Si or Ge insertion changes the molecular orbital energies and HOMO–LUMO gaps, we plotted the total density of states (TDOS) for  $\text{Si}_{19}\text{Cl}_{12}$  and  $\text{Si}_{18}\text{GeCl}_{12}$  in Fig. 5a. The partial densities of states (PDOS) of the inserted atoms are also shown so that their contribution to the TDOS can be evaluated. As a comparison, the TDOS of  $\text{Si}_{18}\text{Cl}_{12}$  is plotted in Fig. 5b. From the graph, one can see that there is almost no difference between the Si insertion case and Ge insertion case in the DOS, both inserted species produce a new state into the forbidden region of  $\text{Si}_{18}\text{Cl}_{12}$ , and hence significantly narrow the HOMO–LUMO gap. This observation is in line with the earlier study of  $\text{Si}_{19}\text{H}_{12}$ .<sup>21</sup> From orbital isosurfaces, we have found this new state is essentially the LUMO of  $\text{Si}_{18}\text{Cl}_{12}$  (the peak at approx. -4 eV in Fig. 5b), the interaction between  $\text{Si}_{18}\text{Cl}_{12}$  and the extra Si significantly shifts down the LUMO energy, and due to the additional electrons brought by the inserted Si, the LUMO finally becomes the HOMO.

We also calculated HOMO and LUMO compositions for all the silicon clusters studied herein to study their characteristics in detail (Table S1†). The table shows that for all cases, the HOMOs and especially the LUMOs, are primarily given from the  $\text{Si}_{18}$  skeleton; the contribution from the inserted atom is

commonly small; only in the case of X = H, the contribution of the inserted atom to the HOMO is notable (23.5% for  $\text{Si}_{19}\text{H}_{12}$  and 33.6% for  $\text{Si}_{18}\text{GeH}_{12}$ ). No general relationship between the characteristics of the X group or of the inserted atom and the HOMO/LUMO composition can be found.

### Orbital interaction analysis

Orbital interaction diagram analysis is a commonly used approach to study how fundamental MOs are mixed to form complex MOs. This analysis helps us in understanding the nature of the frontier MOs of the silicon clusters. The orbital interaction diagram of the representative  $\text{Si}_{19}\text{Cl}_{12}$  is shown in

Table 5 NPA charges of the X groups ( $q_X$ ), peripheral silicon atoms ( $q_{\text{Si-peri}}$ ), middle-layer silicon atoms ( $q_{\text{Si-mid}}$ ) and the inserted atom ( $q_{\text{ins}}$ ) of  $\text{Si}_{18}\text{X}_{12}$ ,  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$ . The valence electron configurations of the inserted atoms are shown in the last column

	X group	$q_X$	$q_{\text{Si-peri}}$	$q_{\text{Si-mid}}$	$q_{\text{ins}}$	Ins. config. <sup>a</sup>
Si <sub>18</sub>	H	-0.122	0.199	-0.154	—	—
	F	-0.608	0.770	-0.324	—	—
	Cl	-0.336	0.430	-0.190	—	—
	Br	-0.234	0.317	-0.167	—	—
	OH	-0.569	0.727	-0.315	—	—
	NH <sub>2</sub>	-0.509	0.652	-0.287	—	—
	COOH	-0.309	0.375	-0.134	—	—
Si <sub>19</sub>	H	-0.119	0.192	-0.006	-0.708	$s^{1.18}p_{x/y}^{1.01}p_z^{1.48}$
	F	-0.610	0.728	-0.112	-0.747	$s^{1.13}p_{x/y}^{1.07}p_z^{1.45}$
	Cl	-0.338	0.396	0.003	-0.710	$s^{1.13}p_{x/y}^{1.07}p_z^{1.42}$
	Br	-0.236	0.287	0.011	-0.676	$s^{1.16}p_{x/y}^{1.06}p_z^{1.37}$
	OH	-0.574	0.688	-0.115	-0.673	$s^{1.12}p_{x/y}^{1.05}p_z^{1.41}$
	NH <sub>2</sub>	-0.513	0.626	-0.128	-0.591	$s^{1.21}p_{x/y}^{1.01}p_z^{1.32}$
	COOH	-0.317	0.356	0.043	-0.727	$s^{1.11}p_{x/y}^{1.04}p_z^{1.51}$
Si <sub>18</sub> Ge	H	-0.127	0.184	0.024	-0.874	$s^{1.23}p_{x/y}^{1.04}p_z^{1.52}$
	F	-0.610	0.729	-0.089	-0.893	$s^{1.24}p_{x/y}^{1.09}p_z^{1.43}$
	Cl	-0.338	0.394	0.029	-0.845	$s^{1.23}p_{x/y}^{1.09}p_z^{1.40}$
	Br	-0.237	0.283	0.046	-0.831	$s^{1.23}p_{x/y}^{1.09}p_z^{1.40}$
	OH	-0.574	0.688	-0.093	-0.807	$s^{1.23}p_{x/y}^{1.07}p_z^{1.40}$
	NH <sub>2</sub>	-0.512	0.621	-0.092	-0.756	$s^{1.24}p_{x/y}^{1.04}p_z^{1.40}$
	COOH	-0.318	0.355	0.072	-0.876	$s^{1.20}p_{x/y}^{1.06}p_z^{1.51}$

<sup>a</sup> z denotes the direction of the symmetry axis of the clusters. Due to symmetry,  $p_x$  and  $p_y$  share the same occupation number and thus they are shown together.

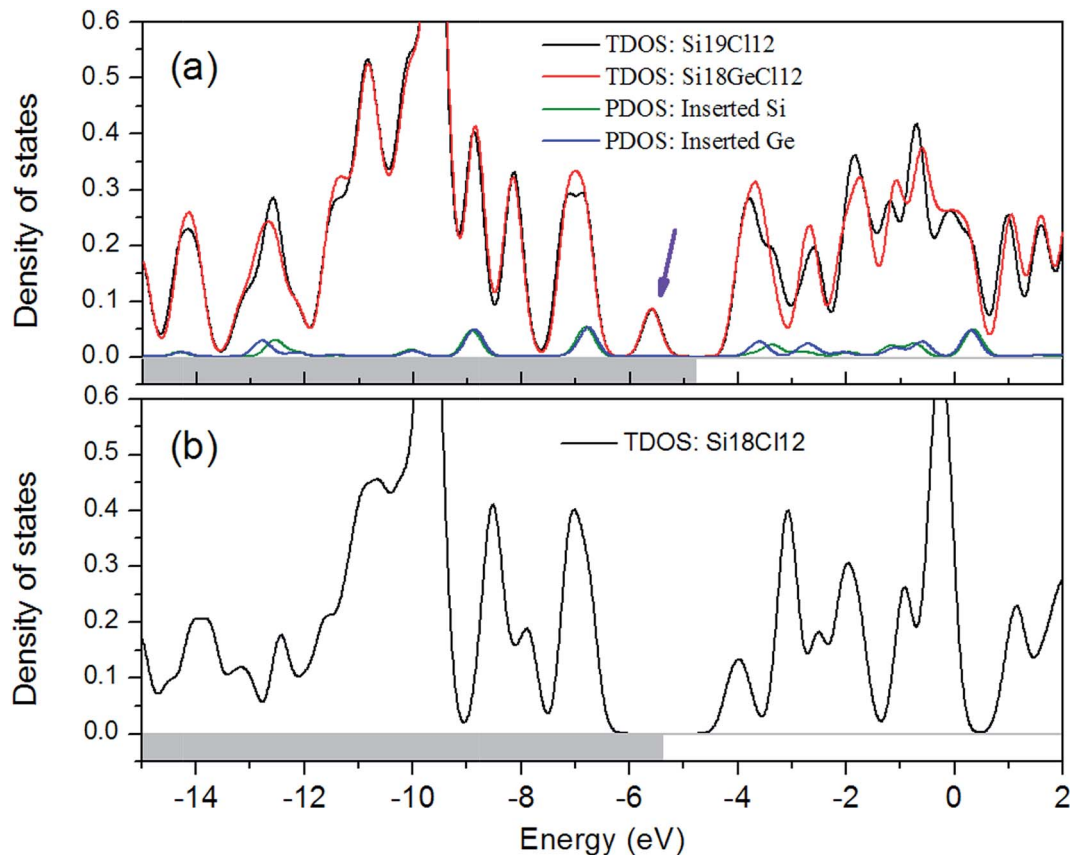


Fig. 5 (a) Total density of states (TDOS) and partial density of states (PDOS) maps for Si<sub>19</sub>Cl<sub>12</sub> and Si<sub>18</sub>GeCl<sub>12</sub>, the purple arrow marks the new state due to the Si or Ge insertion; (b) TDOS map of Si<sub>18</sub>Cl<sub>12</sub>. The DOS value is in arbitrary units. Occupied state regions are shaded for clarity. A Gaussian function with full width at half maximum (FWHM) of 0.4 eV was used for broadening molecular orbital energies to yield the DOS curves.

Fig. 6, the Si<sub>18</sub>X<sub>12</sub> cage and the inserted Si (in  $s^2p_z^2$  configuration) are respectively taken as the two fragments. As highlighted by the pink arrows in Fig. 6, due to the phase matching, the doubly degenerate HOMOs of Si<sub>18</sub>Cl<sub>12</sub> substantially mix with the  $3p_x$  and  $3p_y$  virtual atomic orbitals of the inserted Si and yield two low-lying degenerate MOs of Si<sub>19</sub>Cl<sub>12</sub>. The blue arrows in Fig. 6 highlight that, since the LUMO+1 of the Si<sub>18</sub>Cl<sub>12</sub> has the same orbital phase as the  $3p_z$  orbital of the inserted Si, they are strongly mixed and result in one of the (nearly) triply degenerate HOMO–1 of the Si<sub>19</sub>Cl<sub>12</sub>. The doubly degenerate LUMO of Si<sub>19</sub>Cl<sub>12</sub> directly derives from the doubly degenerate LUMO+2 of Si<sub>18</sub>Cl<sub>12</sub> (see grey arrow in Fig. 6). The most noteworthy MO is the HOMO of the Si<sub>19</sub>Cl<sub>12</sub>, which as mentioned above is crucial for lowering the gap of the Si<sub>18</sub>Cl<sub>12</sub> cluster. As highlighted by the green arrows in Fig. 6, this orbital is essentially the LUMO of the Si<sub>18</sub>Cl<sub>12</sub>, but now occupied by two electrons and the energy is decreased by 0.7 eV. The  $3s$  orbital of the inserted Si (–11.6 eV) and the 221<sup>th</sup> MO of the Si<sub>18</sub>Cl<sub>12</sub> (–7.8 eV) also participate in the HOMO of Si<sub>19</sub>Cl<sub>12</sub>, but the amount can be neglected (1.4% and 5.4%, respectively).

In short, the orbital interaction diagram analysis clearly shows that due to the Si insertion, the characteristics of the frontier MOs of Si<sub>19</sub>Cl<sub>12</sub> distinctly differ from the counterparts of Si<sub>18</sub>Cl<sub>12</sub>; as a result, the HOMO–LUMO gap narrows

significantly. This observation also holds for other X groups and for the Ge insertion case.

### Electrostatic potential analysis

Electrostatic potential (ESP) is a key function for studying and predicting intermolecular interactions and is commonly studied on molecular van der Waals (vdW) surfaces.<sup>53</sup> An investigation on the ESP of the silicon clusters must be very helpful for revealing how the inserted atom and the X groups affect the interactions between the clusters and other chemical species. To intuitively capture the basic characteristics of the ESP distribution on the vdW surface of our series of silicon clusters, we first examine the ESP mapped vdW surface of the representative Si<sub>19</sub>Cl<sub>12</sub>. From Fig. 7, it can be seen that in the top and bottom (or two-ends) regions as well as in the equatorial region, the ESP is quite positive: the maximum value in the former and latter reaches +22.2 and +30.5 kcal mol<sup>–1</sup>, respectively, suggesting that the silicon atoms under these surfaces tend to be attacked by nucleophiles and prefer to bind to Lewis-bases by electrostatic attraction. The ESP on the surface covering the chlorines exhibits small negative values around –6.3 kcal mol<sup>–1</sup>, this observation is consistent with the atomic charge analysis (Table 5), which shows that the NPA charge of the chlorines is negative (–0.34). It is worth noting that at the

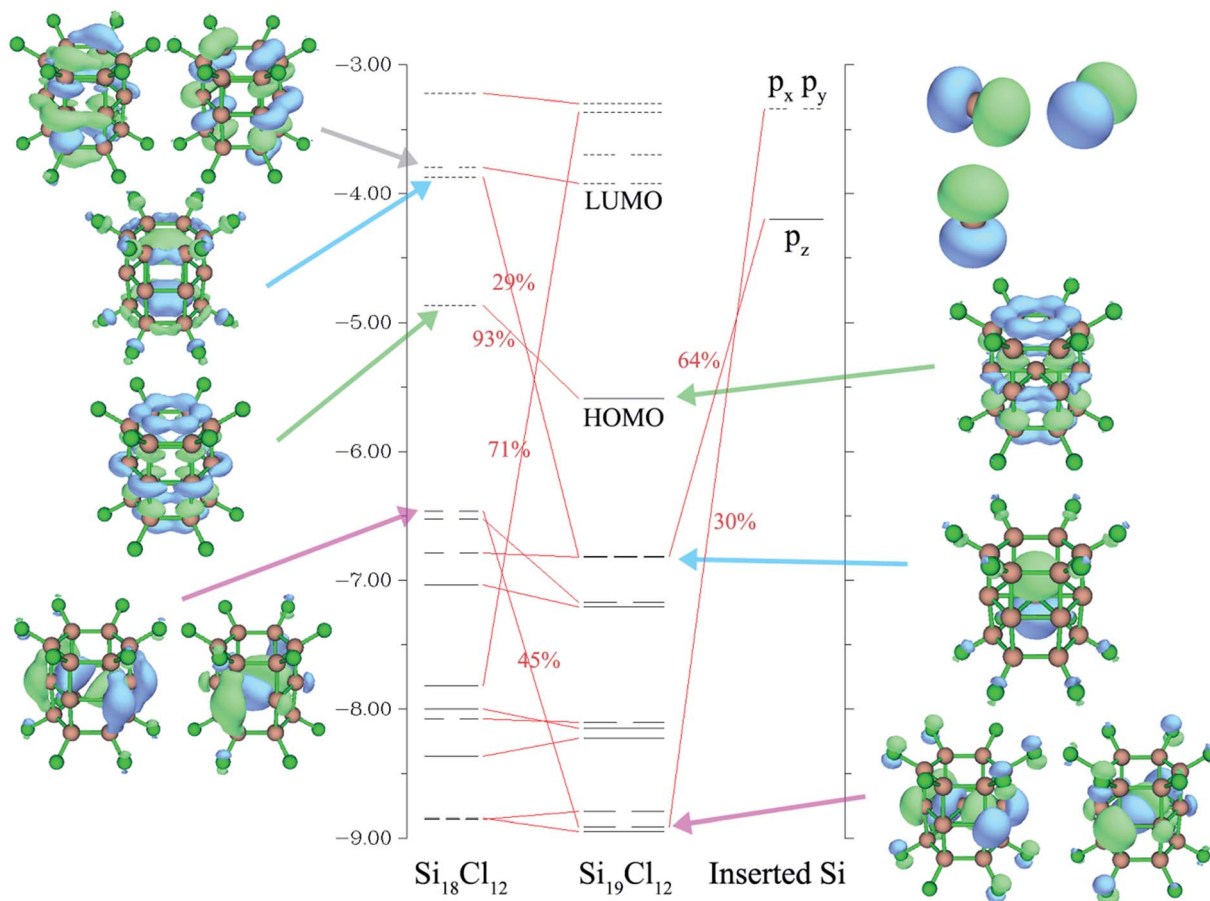


Fig. 6 Orbital interaction diagram for  $\text{Si}_{19}\text{Cl}_{12}$ . The inserted Si takes its  $s^2p_z^2$  configuration. Vertical axis shows MO energies in eV. Solid and dashed bars correspond to occupied and virtual MOs, respectively. The one and two gaps in the bars mean the corresponding states are doubly and triply degenerate, respectively. Some MOs are plotted as isosurface graphs with an isovalue of 0.03. The numbers marked beside the red lines indicate the contribution from the fragmental MO to the  $\text{Si}_{19}\text{Cl}_{12}$  MOs. For clarity, the contributions close to 100% are not labeled, and those smaller than 10% are not highlighted by red lines.

terminal of each chlorine, there is a local maximum of ESP with a small positive value ( $+3.8 \text{ kcal mol}^{-1}$ ), which is known as  $\sigma$ -hole and is the source of the well-known halogen bonds.<sup>53,54</sup> In fact, the  $\sigma$ -hole is present in all the  $\text{Si}_{18}\text{X}_{12}$ ,  $\text{Si}_{18}\text{GeX}_{12}$  and  $\text{Si}_{19}\text{X}_{12}$  clusters when  $\text{X} = \text{Cl}, \text{Br}$ .

It is difficult to graphically compare the ESP on vdW surfaces for all 21 clusters involved in our present work. However, from Fig. 7, we note that it is useful and reasonable to partition the whole vdW surface into three local regions, namely the equatorial region, the “two-ends” region and the X group region; then, it will be straight forward to compare them respectively. So, we employed the local molecular surface analysis function of the Multiwfn program to obtain the average ESP (referred to as  $\bar{V}$ )<sup>55</sup> in the three regions of the local vdW surfaces for all 21 clusters, the results are listed in Table 6. The partition manner is illustrated in Fig. S1.† Table 6 also contains the maximum and minimum values of the ESP over the whole vdW surface. From the table, we have four main findings:

(1) In the equatorial and the two-ends regions of any cluster, when X is a single atom, the  $\bar{V}$  is positive and large, meaning that these areas in this situation are quite favorable for binding a negatively charged substance. When  $\text{X} = \text{H}$  or  $\text{COOH}$ , the  $\bar{V}$  is

still positive, but not so large. In the case of  $\text{X} = \text{OH}$ , and in particular  $\text{X} = \text{NH}_2$ , mostly due to the influence of the electron-rich lone-pair of the oxygen and nitrogen atoms, the  $\bar{V}$  in one of, or in both of the equatorial and two-ends regions becomes

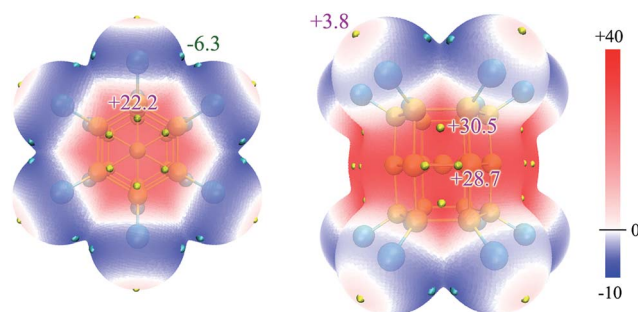


Fig. 7 Top view and side view of the electrostatic potential (ESP) mapped with the vdW surface of  $\text{Si}_{19}\text{Cl}_{12}$ . The ESP values are in  $\text{kcal mol}^{-1}$ . The vdW surface is defined as the isosurface of  $\rho = 0.001 \text{ a.u.}$  Yellow and cyan spheres correspond to the position of local maxima and minima of the ESP on the vdW surface, respectively. ESP values are labeled beside them.

negative, and thus completely loses its ability to attract Lewis-bases electrostatically.

(2) For  $\text{Si}_{18}\text{X}_{12}$ , the  $\bar{V}$  in the two-ends region is more positive than that in the equatorial region, while the situation is completely inverted in the cases of  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$  (the ESP mapped vdW surface of  $\text{Si}_{18}\text{Cl}_{12}$  is given in Fig. S2† and the interested reader can compare it with Fig. 7). This observation can at least partially be explained based on atomic charges; from Table 5, it can be seen that after inserting a Si or Ge atom into  $\text{Si}_{18}\text{X}_{12}$ , the charges of the middle-layer silicon atoms, which dominate the ESP in the equatorial region, become nearly zero.

(3) When  $\text{X} = \text{OH}, \text{NH}_2, \text{COOH}$ , both the global ESP minimum and maximum on the vdW surface occur in the X group region. This phenomenon originates from the electron-rich lone pair of the oxygen and nitrogen atoms as well as the highly positively charged hydrogens. It is expected that the corresponding silicon clusters can easily form hydrogen bonds *via* these X groups. When  $\text{X} = \text{H}, \text{F}, \text{Cl}, \text{Br}$ , the global ESP minimum on the vdW surface always occurs around the X groups, while the global maximum one occurs in the equatorial region for  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$ , and in the two-ends region for  $\text{Si}_{18}\text{X}_{12}$ .

(4) The insertion of both a Si or a Ge atom into the  $\text{Si}_{18}\text{X}_{12}$  cage greatly changes its ESP distribution on the vdW surface. The choice of the insertion atom, however, only has minor effects on the ESP profiles of the nanoclusters.

### Bonding analysis

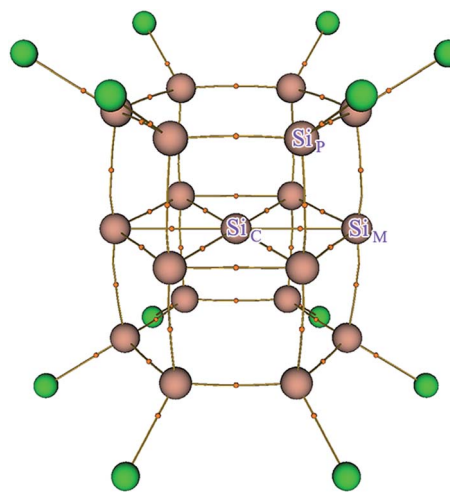
In this section we study bonds in the silicon clusters. Atoms in molecules (AIM)<sup>56</sup> is a very powerful theory for the investigation of bonding interactions. In this theory, critical points are the

**Table 6** Average ESP values on the local vdW surface of the X group region ( $\bar{V}_X$ ), the equatorial region ( $\bar{V}_{\text{equ}}$ ) and the two-ends region ( $\bar{V}_{\text{end}}$ ). The minimum and maximum values of the ESP ( $V_{\text{min}}$  and  $V_{\text{max}}$ ) over the whole vdW surface are also shown

	X group	$\bar{V}_X$	$\bar{V}_{\text{equ}}$	$\bar{V}_{\text{end}}$	$V_{\text{min}}$	$V_{\text{max}}$
Si <sub>18</sub>	H	1.45	3.27	11.63	-1.69	16.37
	F	-1.39	17.93	33.57	-10.67	45.72
	Cl	0.39	18.73	30.33	-5.35	41.30
	Br	-0.05	13.05	23.65	-7.54	33.59
	OH	2.22	-1.64	5.84	-21.57	45.42
	NH <sub>2</sub>	2.16	-15.10	-12.69	-36.27	28.68
	COOH	-2.72	4.05	13.94	-32.41	51.87
Si <sub>19</sub>	H	0.27	8.45	4.47	-3.46	14.72
	F	-2.50	24.00	22.11	-12.00	31.29
	Cl	-0.07	25.69	19.73	-6.41	30.54
	Br	-0.33	19.42	13.64	-9.73	25.59
	OH	1.48	3.55	-2.40	-22.94	43.92
	NH <sub>2</sub>	1.40	-9.13	-20.16	-39.07	29.25
	COOH	-3.01	10.03	5.75	-31.37	51.40
Si <sub>18</sub> Ge	H	0.03	8.76	4.26	-2.75	13.53
	F	-2.54	23.80	21.96	-12.04	31.24
	Cl	-0.21	25.80	19.53	-6.71	30.28
	Br	-0.47	20.10	13.38	-8.58	24.20
	OH	1.44	3.56	-2.72	-22.75	43.61
	NH <sub>2</sub>	1.20	-10.62	-17.37	-34.61	27.69
	COOH	-3.03	10.38	5.39	-31.78	50.56

positions where the gradient norm of the electron density  $\rho$  is zero, which can be further classified according to the sign of the eigenvalues of the Hessian matrix of  $\rho$ . Bond critical points (BCP) have two negative eigenvalues, it usually occurs between interacting atom pairs. The bond path is the trajectory emitted from a BCP by tracing the steepest ascent direction of  $\rho$ , it unambiguously characterizes the interacting path between atoms. All BCPs and bond paths in  $\text{Si}_{19}\text{Cl}_{12}$ , as well as the naming of the silicon atoms are shown in Fig. 8. From the figure one can see that the central silicon atom directly binds to all six surrounding silicon atoms. Bonding interactions are also clearly present between each pair of  $\text{Si}_P\text{-Si}_P$ ,  $\text{Si}_M\text{-Si}_M$  and  $\text{Si}_P\text{-Si}_M$ . The detectable curvature of the  $\text{Si}_P\text{-Si}_M$  bond paths is noteworthy, which implies that due to the cage strain effect the bonding electrons are bulged outwards.

Mayer bond order<sup>57</sup> is a quantity frequently used to study multiplicity of bonds and compare strength of the same kind of bonds. To study the characteristics of the Si-Si and Si-Ge bonds and to reveal the influence of atomic insertion and of the chosen X group, we computed Mayer bond order for all Si-Si or Si-Ge bonds and listed them in Table 7. One first notes that the bond order of most listed bonds is smaller than 1.0, suggesting that, on the average, less than one pair of electrons is involved in each of these bonds. This observation is in line with ref. 21, which showed that most Si-Si bonds in  $\text{Si}_{19}\text{H}_{12}$  are electron-deficient. From Table 7, it can be seen that the order of bonding strength in  $\text{Si}_{18}\text{X}_{12}$  is  $\text{Si}_M\text{-Si}_M > \text{Si}_M\text{-Si}_P > \text{Si}_P\text{-Si}_P$ ; however, after inserting a Si or Ge atom in the cluster center, this sequence is completely reversed: the  $\text{Si}_P\text{-Si}_P$  bond then becomes the strongest one and has higher bond order than before. One possible reason may be that due to the presence of the inserted atom, some electron densities are pushed toward the peripheral silicon atoms from the middle-layer silicon atoms strengthening thus the  $\text{Si}_P\text{-Si}_P$  bonds; this inference can be readily justified by our atomic charge analysis of above (Table 5). For  $\text{Si}_{19}\text{X}_{12}$  and  $\text{Si}_{18}\text{GeX}_{12}$ , the bonding between the



**Fig. 8** Bond paths (brown lines) and bond critical points (orange spheres) of  $\text{Si}_{19}\text{Cl}_{12}$ . The naming of the three kinds of silicon atoms are labeled.

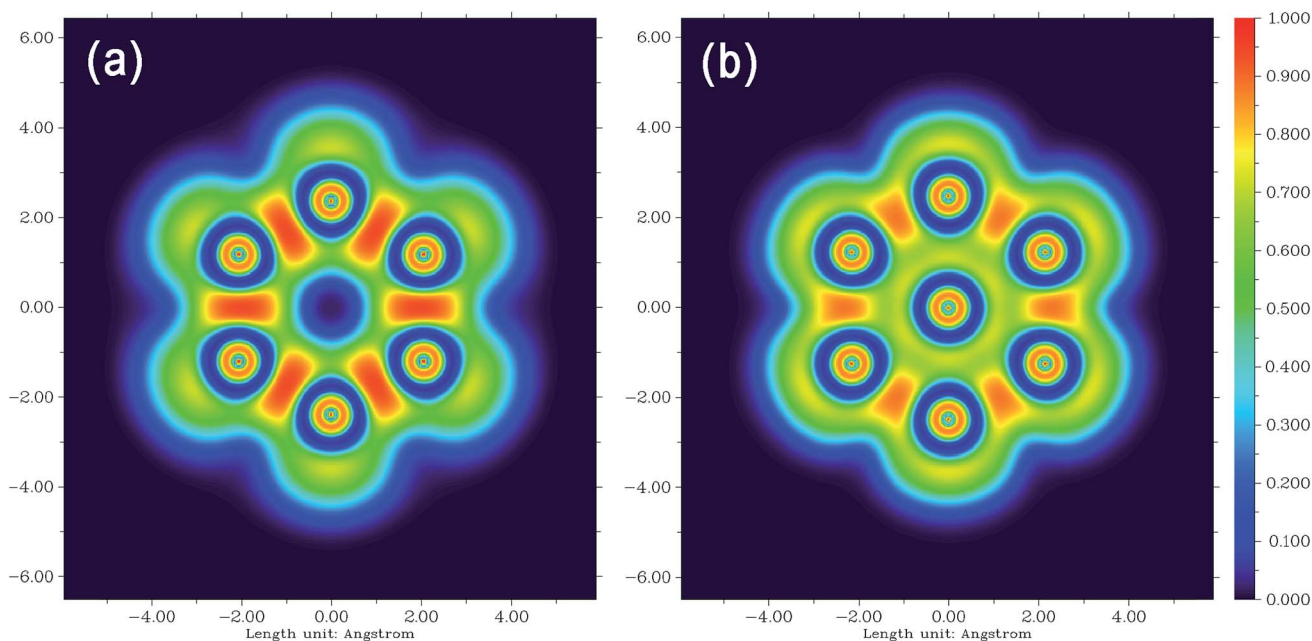
**Table 7** Mayer bond orders of all Si–Si and Si–Ge bonds in all 21 clusters

	X group	Si <sub>P</sub> –Si <sub>P</sub>	Si <sub>P</sub> –Si <sub>M</sub>	Si <sub>M</sub> –Si <sub>M</sub>	Si <sub>M</sub> –Si <sub>C</sub> /Ge
Si <sub>18</sub>	H	0.816	0.841	0.860	—
	F	0.690	0.723	0.778	—
	Cl	0.690	0.767	0.798	—
	Br	0.715	0.780	0.785	—
	OH	0.751	0.713	0.790	—
	NH <sub>2</sub>	0.786	0.756	0.825	—
	COOH	0.779	0.814	0.814	—
Si <sub>19</sub>	H	0.864	0.678	0.556	0.347
	F	0.719	0.565	0.478	0.313
	Cl	0.726	0.602	0.510	0.319
	Br	0.745	0.609	0.505	0.327
	OH	0.781	0.548	0.489	0.331
	NH <sub>2</sub>	0.808	0.589	0.523	0.355
	COOH	0.811	0.656	0.524	0.325
Si <sub>18</sub> Ge	H	0.864	0.685	0.549	0.373
	F	0.718	0.569	0.476	0.353
	Cl	0.727	0.603	0.506	0.354
	Br	0.750	0.611	0.495	0.356
	OH	0.780	0.551	0.486	0.367
	NH <sub>2</sub>	0.795	0.603	0.515	0.379
	COOH	0.812	0.657	0.519	0.354

inserted atom and the middle-layer silicon atoms is weak, the corresponding bond order is merely about 0.35; however, since there are six Si<sub>M</sub>–Si<sub>C</sub>/Ge bonds in total, the inserted atom can still be stabilized by the Si<sub>18</sub> cage. The bond order of all bonds, except for the ones directly related to the inserted atom, are rather insensitive to the element of the inserted atom. Regarding the influence of the X group, from Table 7, one can see that the strength of the Si<sub>P</sub>–Si<sub>P</sub> bonds obviously depends on the nature of the X group, the sequence is identical in all

clusters, namely H ≫ COOH ≅ NH<sub>2</sub> > OH > Br > Cl ≅ F. The reason is understandable, that is the hydrogen and fluorine atoms have the weakest and strongest capacity of attracting electrons from the peripheral silicon atoms, respectively, and thus in the former case, the peripheral silicon atoms are able to utilize more electrons to form bonds than in the latter case. The Laplacian bond order<sup>58</sup> which is shown to be very reliable to reveal bonding strength, was also employed by us to study the bonds in these systems, and we found almost identical conclusion as above (data not shown).

The electron localization function is a very powerful tool to study electron localization and delocalization problems.<sup>24,59,60</sup> The ELF values range from 0 to 1, the larger the ELF at a point, the higher the probability that electrons localize around it. ELF is able to fruitfully reveal electronic structure characteristics in chemical systems, such as atomic shells, covalent bonds, lone pairs, as well as electron delocalization channels.<sup>59,61</sup> To further unveil the nature of the interaction between the inserted atom and the surrounding ones in the clusters, we plotted ELF maps in the plane through the middle-layer silicon atoms for Si<sub>18</sub>Cl<sub>12</sub> and Si<sub>19</sub>Cl<sub>12</sub> in Fig. 9. From the figure, one can see that there is a yellow circle around the central silicon atom, which directly corresponds to the electrons weakly and covalently shared by the central and middle-layer silicon atoms. It is also expected that the electrons are relatively easy to delocalize around the central silicon atom by passing through the yellow circular channel. Concerning the cost of formation of the Si<sub>M</sub>–Si<sub>C</sub> covalent interactions, it is seen from Fig. 9 that the degree of electron localization between Si<sub>M</sub>–Si<sub>M</sub> is markedly reduced, in other words, the electron delocalization is strongly enhanced. This observation is in line with the above Mayer bond order analysis. We also plotted an ELF map for Si<sub>18</sub>GeCl<sub>12</sub> in Fig. S3,†



**Fig. 9** ELF distribution in the plane through the middle-layer silicon atoms of Si<sub>18</sub>Cl<sub>12</sub> (a) and Si<sub>19</sub>Cl<sub>12</sub> (b).

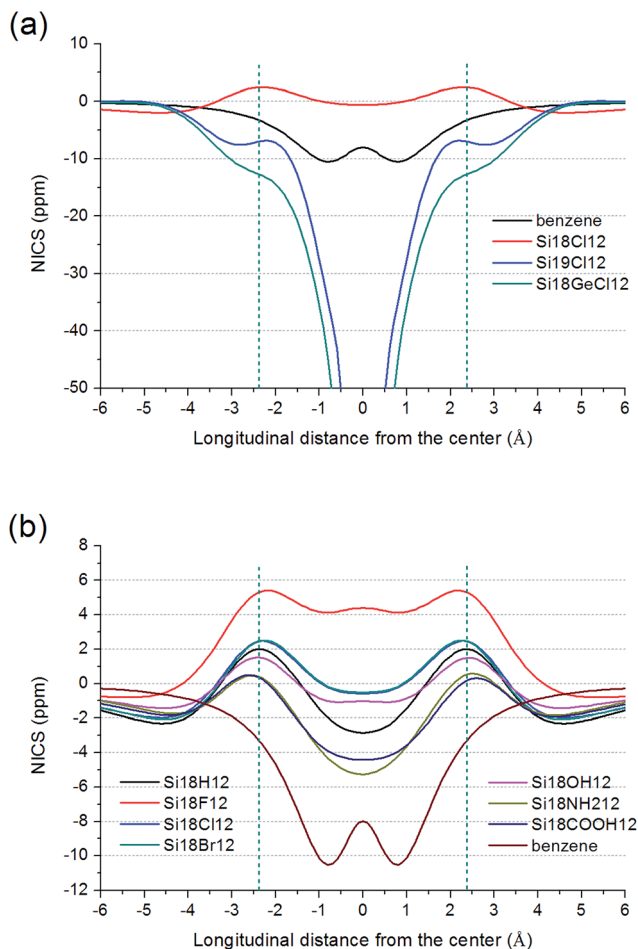


Fig. 10 NICS curves along the symmetry axis of selected silicon nanoclusters. The curve of benzene is also shown for comparison. The two vertical dash lines correspond to the position of the peripheral silicon atoms.

the characteristics of its ELF pattern is similar with that of Si<sub>19</sub>Cl<sub>12</sub>.

### Aromaticity

Aromaticity is an interesting theoretical property of the silicon clusters studied here and highly worthy to be investigated. The most popular index for measuring aromaticity is the Nucleus-Independent Chemical Shift (NICS)<sup>25</sup> which denotes the negative of the isotropic magnetic shielding tensor. For cylindrical clusters, a more thorough way to characterize aromaticity may be plotting the NICS curve along the symmetry axis of the cluster. We did this for all clusters involved in our present investigation. The results for the representative Si<sub>19</sub>Cl<sub>12</sub> and Si<sub>18</sub>GeCl<sub>12</sub>, as well as all Si<sub>18</sub>X<sub>12</sub> clusters are shown in Fig. 10; the NICS curve of benzene is also given in Fig. 10a for comparison. From Fig. 10a, it can be seen that Si<sub>18</sub>Cl<sub>12</sub> does not show any evident aromaticity or antiaromaticity characteristics, since its NICS curve is around zero in the whole range; while after inserting a Si or Ge atom into the cluster center, the aromaticity becomes significant and even stronger than benzene, which is

the reference of aromatic species. This observation is consistent with our above ELF and Mayer bond order analyses; *i.e.*, the Si or Ge insertion weakens electron localization, and as a result, aromaticity enhances due to easier electron delocalization. From Fig. 10a, it is also clear that Ge insertion makes aromaticity slightly stronger than Si insertion. Notice that the occurrence of very negative values in the middle region of the NICS curve of Si<sub>19</sub>Cl<sub>12</sub> and Si<sub>18</sub>GeCl<sub>12</sub> is because the sample points exactly cross the inserted atom, whose inner-core electrons shield external magnetic fields significantly. However, this does not hamper fair comparison of aromaticity, as long as the middle region of the NICS curves is ignored.

The NICS curves of Si<sub>18</sub>X<sub>12</sub> in Fig. 10b demonstrate that the choice of the X group is able to modulate cluster aromaticity to some degree; specifically, from weak aromaticity to weak antiaromaticity. Among all the seven Si<sub>18</sub>X<sub>12</sub> clusters, Si<sub>18</sub>(NH<sub>2</sub>)<sub>12</sub> has the strongest aromaticity, though it is still weaker than benzene. The NICS curve of Si<sub>18</sub>F<sub>12</sub> is obviously positive in the whole range, and thus one may conclude that this cluster possesses a weak antiaromaticity character. We also calculated and plotted NICS curves for all Si<sub>19</sub>X<sub>12</sub> and Si<sub>18</sub>GeX<sub>12</sub> clusters, see Fig. S4a and b,<sup>†</sup> respectively. It is also seen that their aromaticities are somewhat affected by the nature of the X group.

## Conclusions

This study shows a comprehensive combination of gap analysis, charge-transfer analysis, absorption spectra analysis as well as in-depth electronic structure analyses based on density functional theory and wave function studies for a set of silicon nanoparticles with potential applications in photovoltaic and nanotechnological systems. The calculations show a series of new patterns for optical, chemical, electronic, and conductive properties, which can be attributed to the special structure and modifications by various substitutional molecular groups of silicon nanoparticles. Examples of these findings are how the modifications are able to increase or decrease aromaticity of the silicon clusters, depending on the choice of the substitutional groups, a feature which is critical for frequency tuning in nanoelectronics and nanophotonics. The results show also that if arranged in crystal-colloids or active surfaces and coatings, the various configurations of silicon clusters with different groups can provide modifications for tailoring photovoltaic or nanotechnological devices to special needs. Furthermore, systems with organic modifications reduce charge-transfer properties of the silicon particles. However the internal electronic configurations give a set of effects which can prove useful to provide higher chemical stability and applications toward various areas of research, such as ultra-aromaticity, spanning electronic properties with relevance to tunable electronics as well as combinatory nanoengineering with nanoelectronic devices, and Shottky contacts. This extensive study shows also that the pristine systems retain the highest conductive potential as a conductive material or nanoparticle ensemble, if the nanoparticles are arranged in *D*<sub>6</sub> symmetries, sharing a common principal axis of rotation. The results presented here

are valuable for future engineering of nanoparticles and voltage-dependent nanotechnologies based on silicon nanoclusters with modifying substitutional groups.

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